

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Hameed A. NASEEM et al.

Appln. No.:

Filed: Herewith

For: METHOD OF DOPING SILICON, METAL DOPED SILICON,
METHOD OF MAKING SOLAR CELLS AND SOLAR CELLS

* * *

CHANGE OF CORRESPONDENCE ADDRESS

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

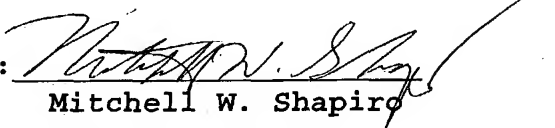
Effective immediately, please address all further
correspondence in the above-identified application to:

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Respectfully submitted,

MWS:lmb

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July 14, 2003

By: 
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